Notice	of References	Cited
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Application/Control No. 10/705,205		Applicant(s)/Patent Under Reexamination CHOI ET AL.		
Examiner	Art Unit			
DEWANDA SAMUEI	2464	Page 1 of 1		

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-6,587,680	07-2003	Ala-Laurila et al.	455/411
*	В	US-7,103,359	09-2006	Heinonen et al.	455/436
*	С	US-2004/0039817	02-2004	Lee et al.	709/225
*	D	US-6,061,563	05-2000	Lee, Myung-Hwan	455/435.1
*	Е	US-6,360,264	03-2002	Rom, Raphael	709/227
*	F	US-6,332,077	12-2001	Wu et al.	455/432.1
	G	US-			
	Н	US-			
	1	US-			
	J	US-			
	К	US-			
	L	US-			
	м	US-			

FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS						
*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	s					
	Т					

NON-PATENT DOCUMENTS

*		NONFAIRNI DOCUMENTS
*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	v	
	w	
	×	

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